

Figure 1
(Prior Art)

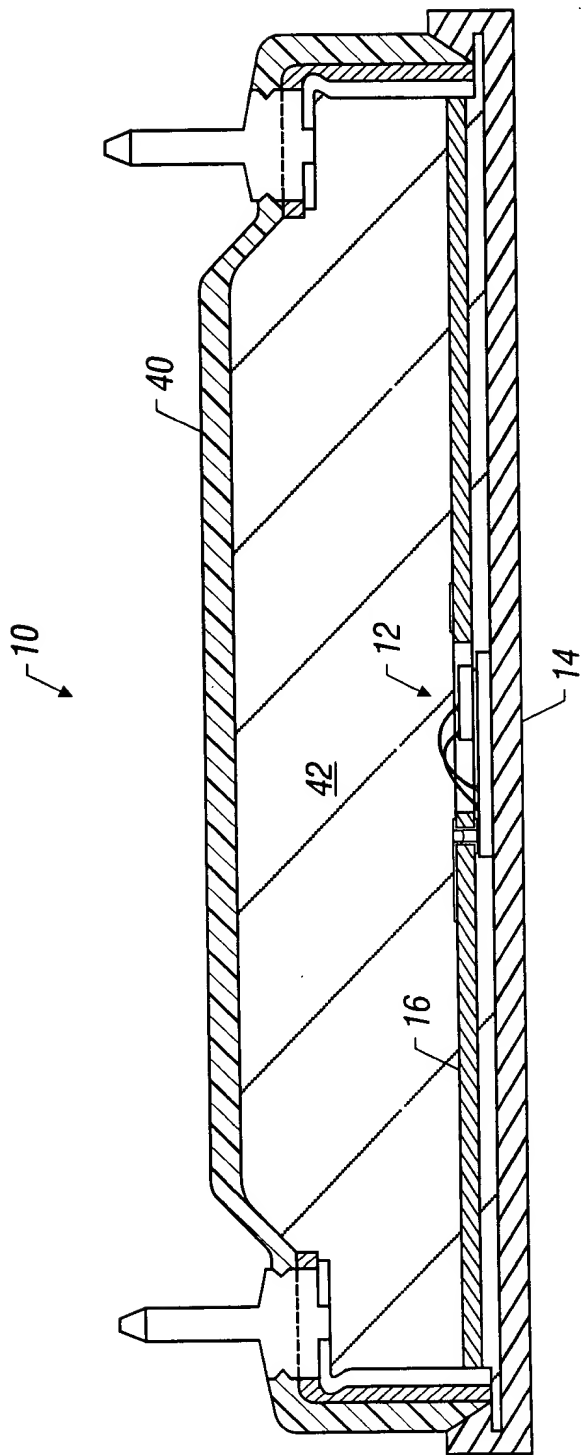


Figure 2

Figure 4

Figure 4

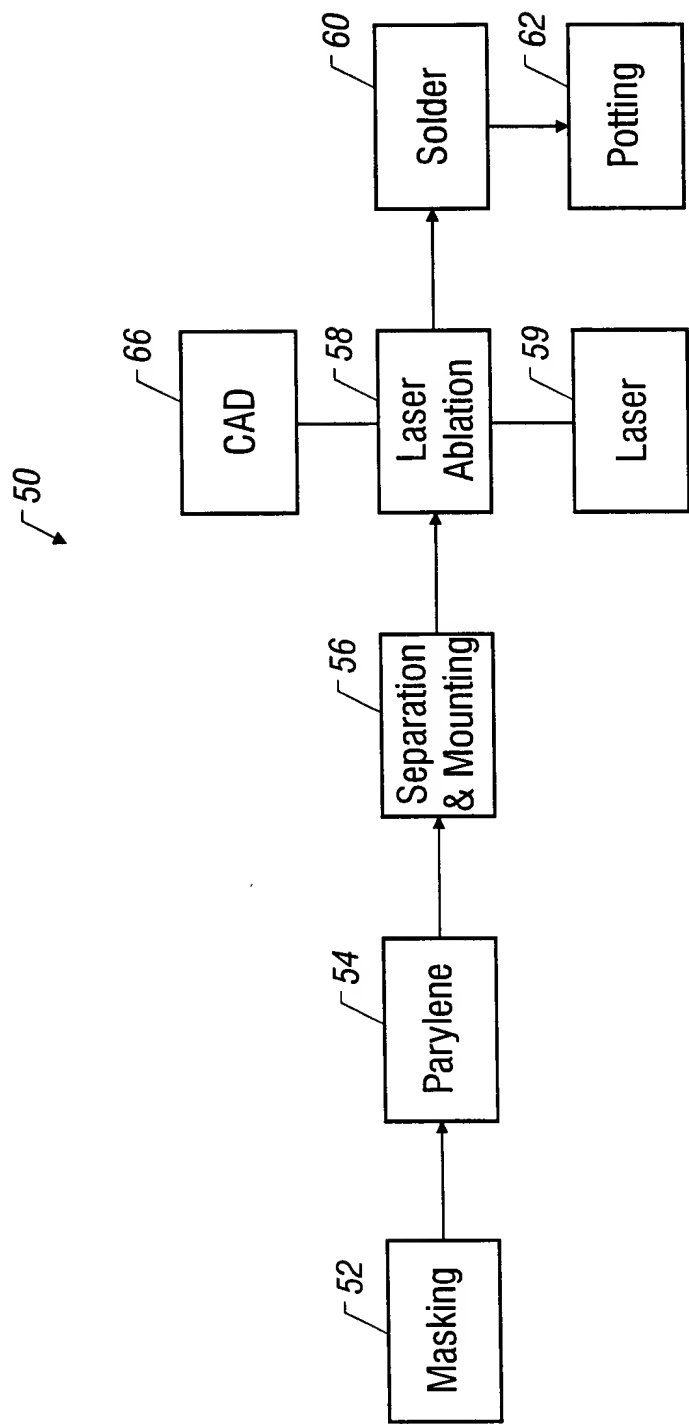


Figure 5

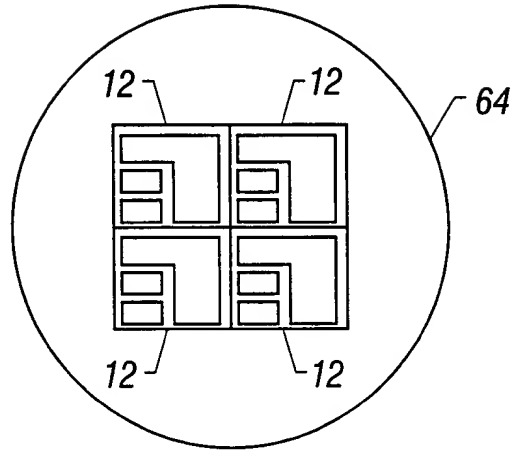


Figure 6

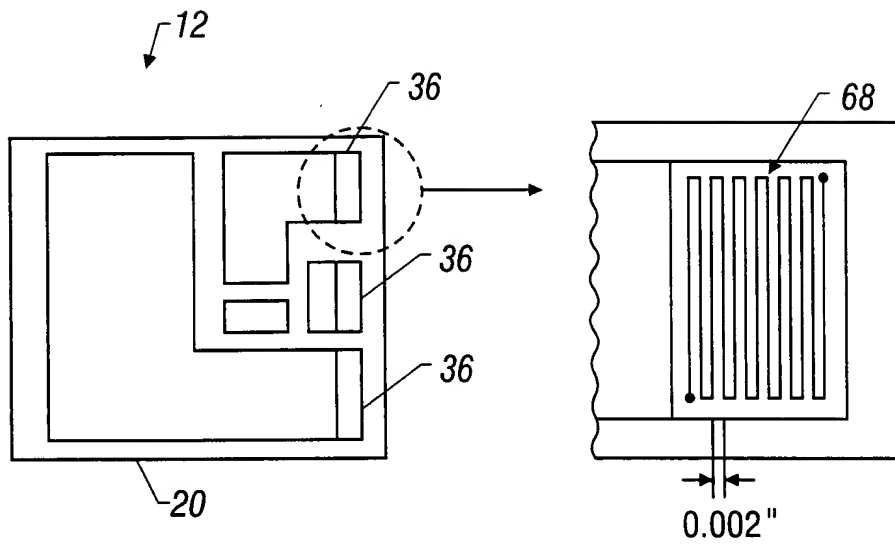


Figure 7

FIG. 8 is a flowchart of a method for fabricating a microelectronic device in accordance with the present invention.

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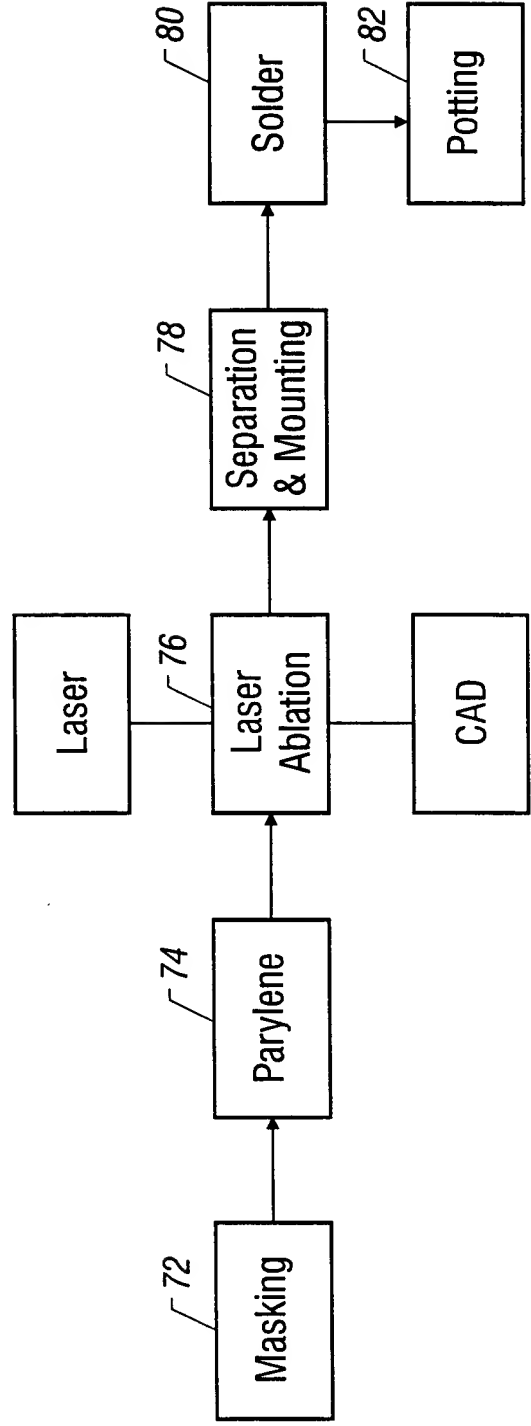


Figure 8

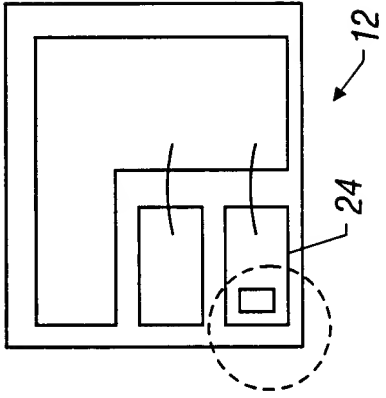


Figure 9A

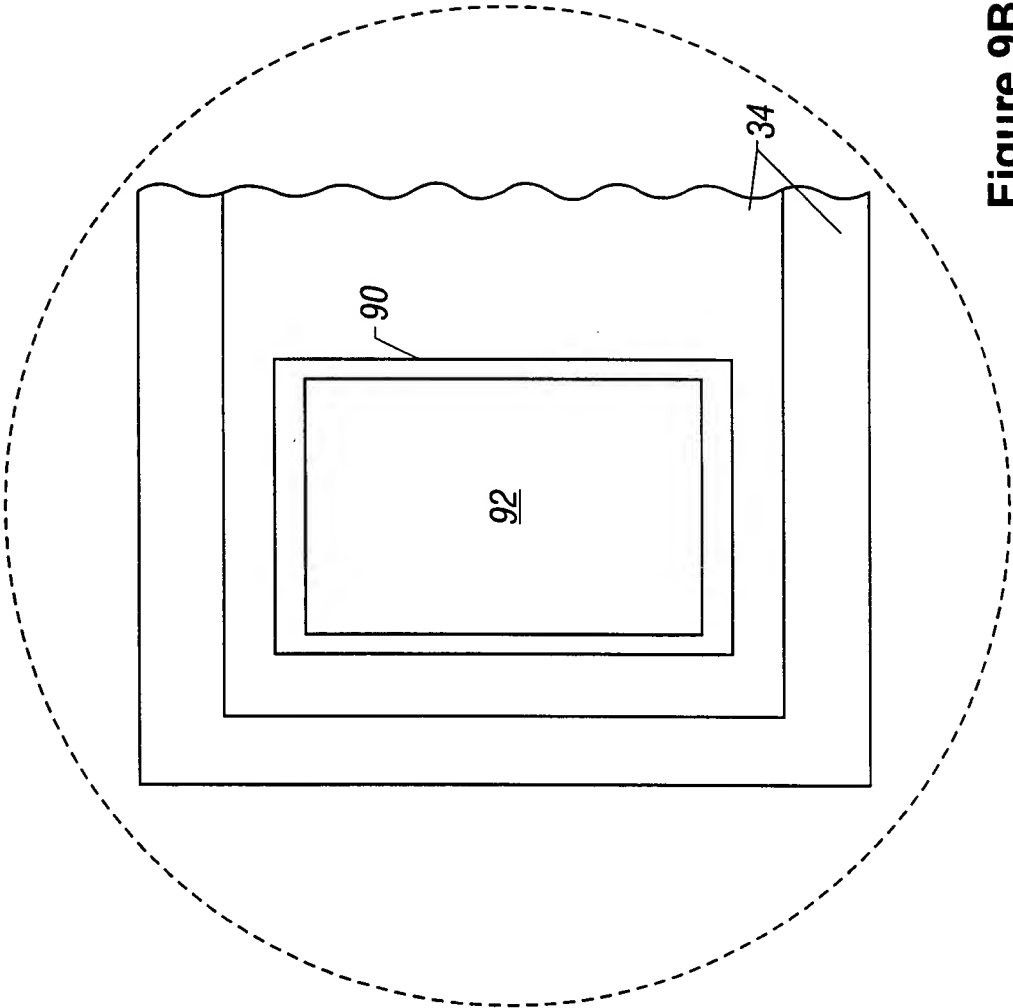


Figure 9B

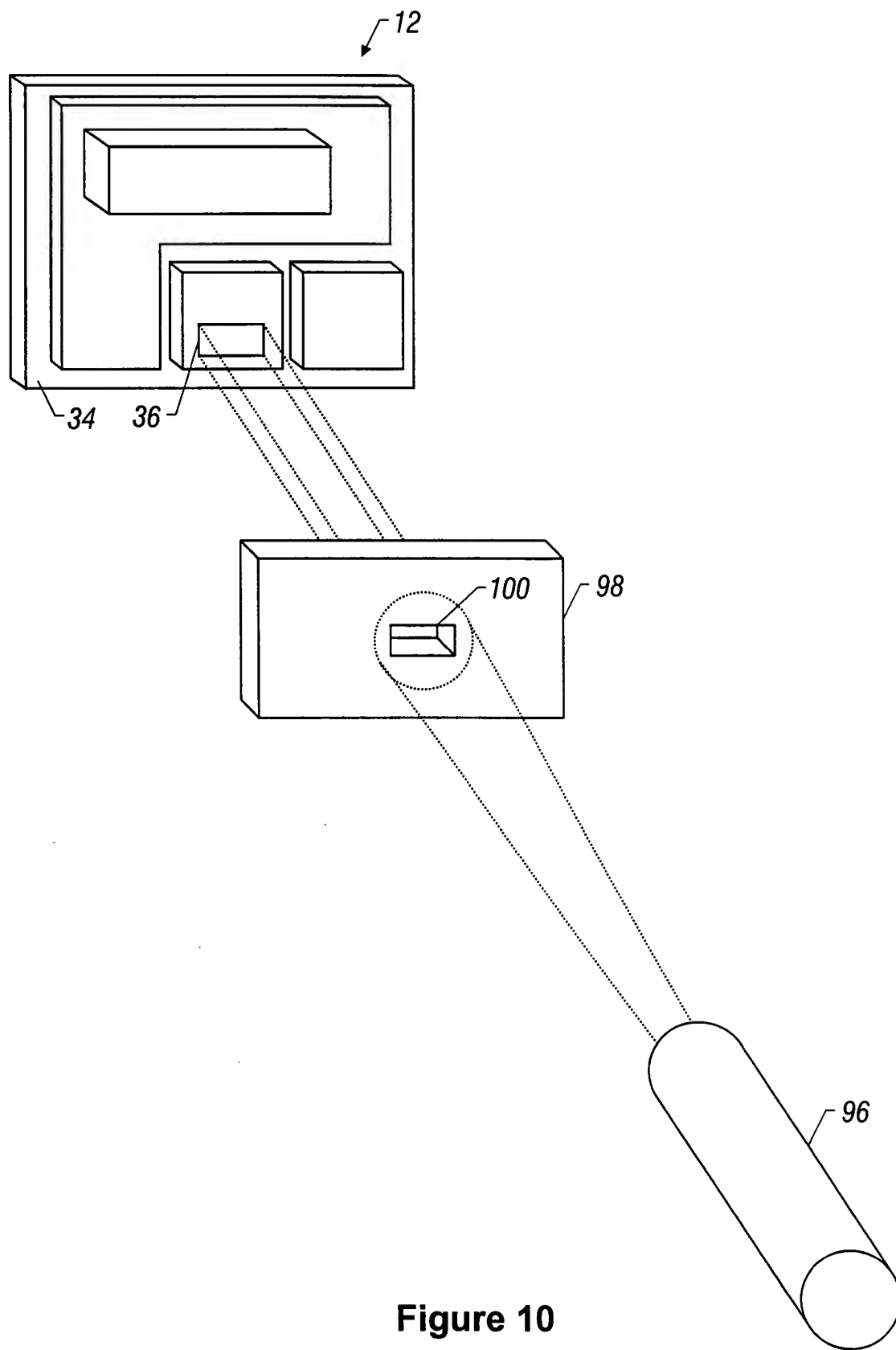


Figure 10